Ab Initio Study of Substitutional Chlorine and Related **Complexes in GaN**

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Introduction

Reactive ion etching (RIE) is typically employed in device processing, e.g., mesa etching. Cl-based RIE is known to:

- Decrease Ohmic contact resistivity in n-type GaN [1,2]
- Reduce carrier concentration in p-type GaN [3]

This was attributed to the formation of nitrogen vacancies (V_N) or V_N -complexes ($V_N V_{Ga}$). However, V_N behaves as a donor in ptype GaN and not in n-type GaN (neutral). In addition, divacancies appear only after high temperature treatment. For these reasons, we investigated the role of Cl in GaN. This is done by employing density functional theory (DFT).

Results

We first analyzed the Mg_{Ga} acceptor and V_N donor, by employing the Makov-Payne [4] or the potential alignment [5] corrections to E_{FORM}. The latter gives better results and has been used throught the present work.

Computational Details

SIESTA spin-polarized DFT calculations. We used:

- a 96-atom supercell
- LDA (CA)
- Troullier-Martins norm-conserving pseudopotentials
- double- ζ plus plus polarization as atomic orbital basis set
- Charge density projection with an equivalent cutoff of 375 Ry
- 8 Monkhorst-Pack special k-points

The d-orbital electrons were treated as valence electrons. Equilibrium configurations of the pristine and defected supercell were obtained by relaxing the atomic coordinates by a CG algorithm

- max atomic forces <0.025 eV/Å
- stress tensor <0.5 GPa.

The formation energy (E_{FORM}) was calculated by using Zhang-Northrup formalism.

| Correction | Mg_{Ga} | V _N |
|---------------------|-------------------------|----------------|
| Makov-Payne | E _v +0.35 eV | No Negative-U |
| Potential alignment | E _v +0.20 eV | Negative-U |

Substitutional CI is more stable at N- (CI_N) rather than Ga-site (Cl_{Ga}) by 2 eV.

 Cl_{N} : after geometry relaxation, a T_{d} symmetry is observed.

Average CI-Ga bond length=2.4 Å

Average Ga-Cl-Ga bond angle=110.1°

Number of electrons (Watkins model)=10

These can be accommodated in two singlet (a_1) levels and one triplet level (t_2) . It can be predicted that Cl_N is a double donor (oxygen is a single donor).

 $Cl_N Mg_{Ga}$: geometry relaxation shows that this defect has C_1 symmetry.

Cl-Mg bond length=2.27

Average Ga-Cl-Mg bond angle=108.3°

Average Ga-Cl bond length=2.34

Average Ga-Cl-Ga bond angle=110.5°

Number of electrons (Watkins model)=9

These can be placed in singlet (a) levels, so there is one spare electron. This defect can be a donor (or an acceptor).

 $Cl_N V_{Ga}$: the relaxed structure has C_{3v} symmetry. Average Ga-Cl bond length=2.34 Å Average Ga-Cl-Ga bond angle=95.6° Number of electrons (Watkins model)=7 These electrons can be found in two singlet (a_1) levels and one doubly degenerate (e) level. Similarly to $Cl_N Mg_{Ga}$, the level can be predicted to be a donor (or an acceptor).



 Cl_N is a double donor for any Fermi energy (E_F) value in the Kohn-Sham band gap.

 Cl_NMg_{Ga} is a single donor for any E_F in the band gap.

For both defects, the E_{FORM} is negative, especially in the case of p-type GaN.

 $Cl_N V_{Ga}$ displays two transition levels: a donor level at $E_V + 0.58 \text{ eV}$ and an acceptor level at E_v +1.4 eV.

Conclusions

Cl in GaN (and complexes) behave as donors.



The relatively low E_{FORM} of Cl_N can explain why Ohmic contacts improve by RIE, in n-type GaN. Furthermore, the low E_{FORM} of Cl_NMg_{Ga} can explain why RIE reduces the hole concentration in ptype GaN.

Investigation of $Cl_N Si_{Ga}$, Cl_i (and complexes) is in progress.

Bibliography

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